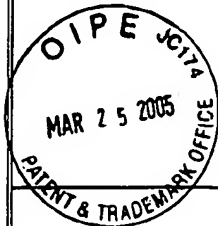


# INFORMATION DISCLOSURE CITATION IN AN APPLICATION



(PTO-1449)

ATTY. DOCKET NO.  
**059516-0052**

SERIAL NO.  
**10/784,899**

APPLICANT  
**Zi-Kui LIU, et al.**

FILING DATE  
**February 24, 2004**

GROUP  
**1775**

## U.S. PATENT DOCUMENTS

EXAMINER'S INITIALS	CITE NO.	Document Number Number-Kind Code2 (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
<i>BS</i>		US 6,797,341 B2	09/28/2004	Zeng et al.	
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## FOREIGN PATENT DOCUMENTS

EXAMINER'S INITIALS	CITE NO.	Foreign Patent Document Country Codes-Number + -Kind Codes (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines Where Relevant Figures Appear	Translation Yes No

## OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER'S INITIALS	CITE NO.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.
<i>BS</i>		ZENG, Xianghui., et al. "In situ epitaxial MgB <sub>2</sub> thin films for superconducting electronics." Nature Materials, Volume 1, September 2002, www.nature.com/naturematerials pp. 1-4

EXAMINER

*B. J. Talbot*

DATE CONSIDERED

*8/30/05*

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.